Electronics for Photodetectors

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New Developments In Photodetection

July 4th-8th 2011, IPN Lyon

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Thanks to

Christophe de la Taille Jacques Lecoq Eric Delagnes Hervé Grabas Dominique Breton Thanh Hung Pham Hervé Lebbolo Kholdoun Torki

and many others...

- Introduction
- Contexts
 - High Energy Physics
 - Space, Medical
- Photodetectors
 - Vacuum
 - Solid state
- Photodetectors Electronics
 - Technologies,
 - Photon counting
 - Amplitude, charge
 - Imaging
 - Timing
 - 3D integration
- Conclusion

Introduction



Photon Electron interaction



Photon-atom interaction:

-

- No absorption : Rayleigh elastic scattering
 - Energy change, absorption:
 - Compton effect: photon scattered with wavelength change no electron ejected
 Photo-electric effect: electron ejected
 e+ e- pairs generation (γ rays): 2 x 511 keV minimum energy

no electron ejected

« Shower » in a « radiator » measured in a (photo)-detector

Photo-detectors

Vacuum devices

- Photo-Multipliers Tubes (PMTs)
- Hybrid Photo-diodes (HPDs)
- Micro-Channel Plates (MCPs)

Solid state devices

- Charge Coupled Devices (CCDs)
- Avalanche Photo-diodes (APDs)
- Silicon Photo-multipliers, (SiPMs, Geiger mode APDs)
- Monolithic Active Pixel Sensors (MAPS, CMOS Silicon)

Hybrids

- Hybrid APDs (HPD/APD)
- Electron Bombarded CMOS (HPD/MAPS)

Vacuum and Solid-state

Vacuum devices

Current signal from electrons in vacuum

- Large area, large fill factor, poor QE
- Full-custom Photo-cathode
- Electron multiplication, high gain, fast
- Low noise (photo-cathode noise)
- Some sensitivity to magnetic fields (depends on device)
- Readout with external ASICs

Solid state semi-conductor devices

Current signal from e-/holes + avalanche in ½ conductor

- Size limited to a wafer, limited filling factor, high QE
- Spectral response of ½ conductor (Si, GaAs, HgCdTe...)
- Multiplication in high electric fields (depleted PN junctions)
- Noisy due to reverse currents avalanches
- Noise very sensitive to irradiation
- No sensitivity to magnetic field
- Readout easy to integrate + 3D availability

Devices

Vacuum devices

Photo-multipliers Hybrid photo-diodes (HPDs) Electron bombarded CMOS Micro-Channel Plates

Solid state (semi-conductor) devices

Avalanche Photo-diodes Silicon PMs

Hybrids

Electron bombarded Silicon

Vacuum devices Single photo-electrons signals

Silicon Photo-Multipliers (SiPM), Micro-channel Plates (MCP)



Fig. 3. SiPM application for sci fiber MIP detection (at room temperature): comparison with APD [6] (room temperature) and VLPC [7] (6.5°K).

Silicon PMs From B. Dolgoshein et al.

25 µm MCP from P. Hink (Burle-Photonis)

Signal development

Effect of first order passive:



- Current signals occur as long as charges move in the detector gap

Rise time is RC dependent at first order sets the electronics bandwidth for timing

Serial noise proportional to C R small, 50 Ω or less if a common base preamp is used Electronics should not increase C (cables, connectors...) C is the capacitance seen during the rising edge (not a full coaxial cable length)

Signal development (1/2 conductor)



Two types of carriers:

- Electrons
- Holes, 3 times slower in silicon
- 75 electrons-holes in one micron
- APDs and SiPMs:
 - Avalanche process is very fast, RC is observed in practice

Reduce R using a transimpedance or current conveyor input stage

$$i_1(t) = [(i_e(t) + i_h(t))][1 - exp(-t / RC)]$$

Electronics and Signal Processing



Detector model

- Almost no amplification needed with PMTs, MCPs, SiPMTs 1 electron is 5mV in 50 Ω with a detector gain of 10⁶⁻⁷ Or current conveying using common base input stage

- Amplification for 10³ to 10⁶ detector gains of (G)APDs, CCDs

- Filtering: "Pulse shaping" to remove amplifier noise out of the signal's frequency content

- Digitization: Convert to a sequence of numbers using ADCs

- Feature extraction: get time, amplitude, charge... Can digital filter as well, remove pedestals

- Send results to user: normalize, compress, error recover...

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High Energy Physics: Calorimetry

Calorimetry:

Showers develop in heavy materials Lead glass, Tungsten...

- High energy particles converted in scintillators into « showers »



Jean-Francois Genat, New Developments in Photo-detection, July 4-8th 2011 Lyon, France

ATLAS Hadron Calorimeter ATLAS TileCal

Constraints for the front-end electronics

- Photo-multipliers rise time : 5 ns
- Least significant charge: 25 fC (20 MeV muon)
- Largest charge: 1.6 nC
- For noise and LSB of 12,5 fC
- The corresponding currents are:
 - 625 nA LSB
 - Max: 40mA

Large dynamic range, 16-bits

A multi-gain design is required

New photo-detectors for Calorimeters Avalanche Photo-Diodes

- Array of avalanche photo diodes: "digital" photon detection
 - Array can be 0.5x0.5 up to 5.0x5.0 mm²
 - Pixel size can be 10 up to $100\mu m$
- All APDs connect to a single output
 - Signal = sum of all cells
- Advantages over HPDs:
 - 28% QE (x2 higher) and 10⁶ gain (x500 higher)
 - More light (40 pe/GeV), less photo-statistics broadening
 - Very high gain can be used to give timing shaping/filtering





ACES 2011 J. Nash CMS Upgrade Plans

9 March 2011

New photo-detectors for Calorimeters Silicon Photo-Multipliers

- Reverse biased PN junction operated over breakdown voltage;
 Geiger Avalanche triggered by the incoming photo-electron in the high electric field.
- Needs « quenching » to stop the current: biasing through a large resistor that drops the voltage (30-50V)
- A SiPM cell comprises several GAPDs having each a quench resistor, all GAPDs tied in parallel: analog sum
- Gain 10⁵⁻⁷
- High Quantum efficiency (90%) but poor fill factor (quenching access electrodes)
- High dark counts, optical crosstalk, dead time,
- High Voltage process +CMOS readout (Philips patent)
- R. Mirzoyan (MePhy, MPI)

http://heapnet.mppmu.mpg.de/documents/oct_07/03_Photodac-07-Mirzoyan.pdf



N

HIGH VOLTAGE

AVALANCHE

P⁻

High Energy Physics: Particle ID

Particle Identification:



Improved with 100ps resolution Time of Flight

Example:

Fast timing readout using 10 GS/s Analog Memory ASIC (SCA):



	SPECIFICATION	ACTUAL	
Sampling Rate	500 MS/s-17GS/s	2.5 GSa/s-17GS/s	
# Channels	4	4	
Sampling Depth	256 cells	256 Cells	
Sampling Window	256*(Sampling Rate) ⁻¹	256*(Sampling Rate) ⁻¹	
Input Noise	1 mV RMS	1-1.5 mV RMS	
Analog Bandwidth	1.5 GHz	Average 600 MHz	
ADC conversion	Up to 12 bit @ 2GHz	Up to ~10 bit @ 2GHz	
Latency	2 µs (min) – 16 µs (max)	3 μs (min) – 30 μs (max)	
Internal Trigger	yes	yes	

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Space applications

Imagers

Space boarded Telescopes

Need to observe single photons with fair position resolution in all spectral domains, in particular (near to far) infra-red

Pixellated devices such as Charge Coupled Devices, Photo-detectors can be:

- Silicon in the visible
- Compounds materials
- CdTe for soft Xrays
- CdZnTe for hard Xrays
- InGaAs for near IR
- HgCdTe for far IR

Pixels as small as 5 x 5 μ m, can be instrumented. Passive (CCDs) or active (Active Pixel Sensors)

Space boarded X ray detectors for imaging and spectrometry http://www.jwst.nasa.gov/

« Asynchronous » events (no trigger)

Jean-Francois Genat, New Developments in Photo-detection, July 4-8th 2011 Lyon, France

JWST





JWST Focal Plane Array

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PET CT High/low

3. Résultats Comparaison d'images: basse dose/haute dose



10 - Optimisation de la TEP-TDM dans le bilan d'un lymphome- Institut Curie- ROUSSEAU Aline - 13/04/2007

« Asynchronous » events (no trigger)

PET + CT TOF-PET



TEP et CT fusionnés

Combined PET-CT

Non-TOF



AREVA

W.W. Moses

« Asynchronous » events (no trigger)

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Timing-Imaging Device (visible)

Multi-anodes PMTs Dynodes

Hybrid Photo-Diodes Electrons on Silicon EBCMOS

Silicon-PMTs Quenched Geiger

mm

Pixels of the SiPM

SiPM

Micro-Channel Plates Micro-Pores



Quantum Eff.	25%	25%	90%	25%
Collection Eff.	90%	90%	70%	70%
Gain	10 ⁶	10 ²⁻⁴	10 ⁶	10 ⁶
Rise-time	1-5ns	1-5ns	250ps	50-500ps
Timing resolution (1PE)	150ps	100ps	100ps	20-30ps
Pixel size	2x2mm ²	10x10μm ²	50x50μm²	1.5x1.5mm ²
Dark counts	1-10Hz/cm ²	1Hz-40kHz/cm ²	1-10MHz/pixel	1Hz-1kHz/cm ²
Dead time	5ns		100-500ns	1μs
Magnetic field	no	1.5T	yes	1.5T
Radiation hardness			1kRad=noisex10	good (glass, Al_2O_3)

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Large Area Micro-Channel Plates



20 x 20 cm² MCP structure:

- Custom photo-cathode
- 2-plate chevron (high gain)
- Transmission line 2D readout

limit the number of electronics channels





Electronics:

- GS/s Flipped-Chip ASICs:

Waveform Sampling + Digital Signal Processing

Micro-Channel Plate Signals



Time response curves for two models of PMT110 with different MCP pore diameters.

From Photek

The fastest photo-detector to date

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APDs

Multiplication initiated by electron-hole, thermally or induced within the APD and accelerated in the high electric field at the APD junction.

Proportional mode

- Bias: slightly *BELOW* breakdown
- Linear-mode: it's an AMPLIFIER
- Gain: limited < 1000

Geiger-mode

- Bias: ABOVE breakdown
- Geiger-mode: it's a *TRIGGER* device!!
- Gain: meaningless ... or "infinite" !!

A. Dieguez (U Barcelona)



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Typical Readout Components



Present trends: Move ADC to Front-end and Amplifier to Detector

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Technologies

Best results in analog design

ASIC implementation at the transistor level

Position resolution require smaller pixels Increased on-pixel signal processing up to ADCs

Thinner feature size processes (65nm and less are coming...)

Available technologies

- Standard Deep Sub-Micron CMOS down to 65nm
- High voltage CMOS

Large dynamic range readout (but multi-gain possible with std CMOS) CCD clocks generation

- Silicon Germanium (SiGe) for faster and low 1/f noise applications
 - Higher mobility (GBW=300GHz)
 - Larger current gain (beta)
 - CMOS compatible (0.25 or 0.35µm) for mixed-signal design 34

ASICs feature size

The smaller the components, the faster, the less power, the greater density

BW = $1/2\pi RC$, $W_c = CV^2$ ENC $1/C_{det}$

Reduce capacitances wherever possible



Moore's law: 1968 Computing power will double every two years, for approximately the same cost

ASICs integration level

Nombre de


Noise vs Technology

ENC for various technologies



Noise vs gate length



M. Manghisoni

ASICs Costs

Costs of MPW (Source: Europractice) <u>http://www.europractice-ic.com</u>

Process	Feature	Cost Eur/mm ²	
CMOS 180nm		0.6k	UMC
180nm	HV 50V	1.2k	AMS
130nm		1.1k	UMC
90nm		2.8k	
CMOS 350nm	Opto	0.7k	AMS
SiGe 350nm	-	0.9k	AMS
250nm	30 GHz	1.9k	IHP
	180	4.4k	
130nm+ CMOS 300		5.4k	IHP
	400	6.0k	

50-100 parts / MPW run Some minimum area (25, 16, 12 mm required)

Masks (production): 100-200k

Packaging

Ceramic: 20-30€/chip Plastic : 2k€ + 1-2 €/chip

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Photon Counting

Space and Medical application: no trigger, asynchronous recording High Energy Physics: a beam synchronous signal is usually available

Visible photons have 1 – 3 eV energy

- Photo-cathodes have QEs of 30% at best
- In semi-conductors, gap is 1.12 eV for Silicon, 1.4 eV for GaAs

Only 1 electron-hole pair per photon

Single photon counting, noise below 1 electron

Silicon PM and Vacuum PMT responses compared

http://hepnp.ihep.ac.cn/qikan/manage/wenzhang/20110111.pdf



Silicon PMs (Geiger-APDs) readout



E. Villela et al. NIM A 2010 Readout electronics for low dark count pixel detectors

Quenching resistor: high valueNMOS transistorInhibit / Reset switchesSwitch sensing node to Vdd / GndInvShaping to logic levelsLatchMemorize Inv state on clk1Clk2enable latch on the output bus

Medipix (EUDET)

MEDIPIX1-3 :

Readout chip to be bonded to an imaging semi-conductor detector (X rays)

- Asynchronous for photon counting,
- Time over threshold provides raw energy estimate

MEDIPIX3: Dead-timeless readout (two counters, one counts, one is read)



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Noise



Spectral density S_v is 1/f (log scale)

Total voltage squared noise is:

 $V_n^2 = \int S_v(\omega) d\omega / 2\pi$

45

Amplification: Ideal charge sensitive amplifier



Charge sensitive amplifier Serial noise

Serial noise: preamplifier first stage



Charge sensitive amplifier Parallel noise



Charge sensitive amplifier Total noise



Input transistor sizing

Noise is mainly produced in the input stage, as it is multiplied afterwards by the gain of the other stages The input transistor is critical

MOS transistor Inversion regimes:

Strong linear : $V_{GS} > V_{th and} V_{DS} < (V_{GS} - V_{th})$ $I_D = \mu_h C_{ox} \frac{W}{L} [(V_{GS} - V_{th}) V_{DS} - \frac{V_{DS}^2}{2}]$

Strong saturation: $V_{GS} > V_{th}$: and $V_{DS} < (V_{GS} - V_{th})$

$$I_D = \mu_h C_{ox} \frac{W}{L} [(V_{GS} - V_{th})^2 (1 + \lambda (V_{DS} - V_{Dsat}2))]$$

Weak:
$$V_{GS} < V_{th}$$

 $I_d = I_{d0} \exp \frac{V_{gs} - V_{th}}{nV_t}$

Input transistor sizing

Reduce power going from strong to moderate-weak inversion

- Strong inversion: g_m proportional to W/L $\sqrt{I_d}$
- C_{gs} proportional to WL
- ENC proportional to (Cdet + Cgs)/ $\sqrt{g_m}$
- Optimum W/L: Cgs = 1/3 Cdet
- Large transistors are easy in moderate/weak inversion at low currents

Optimum size in weak inversion

- gm independent of W, L, proportional to Id
- ENC minimal for C_{gs} minimal, provided the transistor remains in weak inversion

MOSFETs models are pretty accurate today, even for deep submicron processes (L <100nm)



Charge amplifier reset



Pulse Shaping



Use **analog filtering** at frequencies that optimize signal/noise E.g. CR RC, CR RC²

or digitize (if speed and power allow) and use **digital filtering**

Pulse Shaping





ENC after CR-RCⁿ Pulse shaping



Equivalent Noise Charge (ENC) = noise charge seen from the input (in electrons)

Series noise in $1 / \sqrt{\tau}$ Parallel noise in $\sqrt{\tau}$ 1/f noise independent of τ 55

ENC optimization in sub-micron CMOS

Example: Charge amplifier for Avalanche Photo-Diodes readout



Exemple of noise minimization vs shaping time and width of the input transistor $\tau_s = 136$ ns, W = 2mm

Switched Integration



- Convolution with a window function (band-pass, Sinc)
- The switch is implemented easily (instead of large resistors)
- Fast reset: no pile-up
- Needs synchronous operations
- Performance similar to CR-RCⁿ

Example Cd(Zn)Te Xrays detectors readout

16 x 16 pixels readout (camera of 2048 pixels / 8 cm²)

- 32-channel front-end self triggering
- RC² shaper
- Peak detector
- Baseline holder (pulses have a long tail due to slow holes in CdTe)
- Variable gain stage, 50, 100, 150, 200 mV/fC
- ENC=68 e- at 5.4 μ s peaking time and 2 pF input capacitance to achieve 1 keV FWHM energy resolution at 60 keV
- 1 MeV dynamic range
- Discriminator, DAC threshold
- AMS 350nm
- SEL Radiation hard library
- 0.8 mW / channel

IdEFX Saclay

Transimpedance amplifier

Gain = R
$$V_s(\omega) / I_{det}(\omega) = \frac{-R}{1 + Z_f / GZ_d}$$

High counting rate

Typically used for optical link receivers

Easily ringing with capacitive detector

Inductive input impedance Leq= R/ ω_c

Resonance at : fres= $1/2\pi \sqrt{L_{eq}C_d}$ Quality factor: Q = R / $\sqrt{L_{eq}/C_dQ}$ > 1/2induces ringing

Damping with capacitance C_f

$$=2\sqrt{\frac{C_d}{RG\omega_0}}$$

Easier with fast amplifiers



C de la Taille

Current conveyor

- Low input impedance
- Dual-gain
- Differential output





Input impedance versus magnitude

Y-1

User: bohner

Graph Window 22

Feb 3, 2010

Date: Feb 3, 2010 4:55:56 PM CET



J. Lecoq



Charge vs Current preamplifiers

Charge preamps

Best noise performance Best with short signals Best with small capacitance detectors

Current preamps

Best for long signals Best for high counting rate Significant parallel noise

C de la Taille

Guidelines for low-noise design

Noise

- Reduce detector capacitance
- Avoid as much as possible connectors and cables, try to digitize on-front-end
- Increase the first stage gain keeping matching with Cdet
- Shape at the optimum frequency range

ADCs (see J. Lecoq presentation in 2007)

Ramp ADCs

Convert to time (TDC). Compare level to a ramp until trigger. Very effective if many channels in parallel (switched capacitors arrays) A few MHz at more.

1 comparator/channel

1 common (Gray) counter

1 ramp generator

Can be speeded up using an analog feedback from already eliminated codes

Successive approximation (SAR)

Compare level bit after bit to bit-voltages references.. Subtract the winner bit up to LSB.

Faster by N/2N Conversion times 1-10 MHz

1 shift register

1 digital to analog converter/channel

1 subtractor/channel

1 comparator/channel

Flash ADCs

Compare level to all possible codings generated from a voltage divider bridge Very heavy, power hungry, but very effective GS/s speeds 2^N comparators/channels

Encoding logic

Pipe-line

Digitize on N-bit, subtract DAC encoded result Multiply residual by 2 to a next identical stage, up to LSB 64 N-bit ADC 1 multiplication by 2 1 comparator

ADCs

it fractional

Pipe-line structure, with two thresholds/bit to manage code borders, delaying decision to the next stage after signal amplified by 2.

Sigma-Delta

Continuously sampling device. One_bit output obtained from comparison between the integral of the previous differences between level and this normalized bit-output. Output oscillates when conversion achieved. Average level of the bits tream is proportional to the input signal level. Low pass filter recovers the digital data in binary format

- Very accurate (>20-bit)
- Very slow (kHz range)
- 1 integrator, 1 comparator, 1-bit DAC/channel

These ADC have replaced ramp ADCs But photo-detection needs mainly ramp ADCs: high channel count to convert in parallel

All ADCs need an input sample and hold device to assert a stable level during conversion

Many hybrid devices, depending on the best case-dependent trade-off between area, power, technology cost e.g. SAR/flash Photo-detectors

Very application dependent: CCD need parallel operation for column readout, pixels can accomodate one low resolution ADC/pixel

http://www.in2p3.fr/actions/formation/microelectronique07/porguerolpdf2007.pdf

Pulse Sampling ADCs, IPs

Trade-off precision / sampling speed / power

Example:

Discrete ADCs on the market

```
24-b Σ/Δ Dual-slope 16-bit SA + Flash
12-b 3.6GS/s
8-b 56GS/s
```

Custom IPs:

AMS 350nm	12-b 1MHz		purchased by IN2P3
TSMC 130nm	14-b 150 MHz	300mW	nSilition (Belgium)
SOS 90nm	12-b 220 MHz	50mW	Anacatum (Sweden)
Chartered 350nm	8-b 40 MHz		NTLab (Russia)
IHP BiCMOS 250nm	14-b 25 MHz		NTLab (Russia)
IHP BiCMOS 250nm	2x 12-b 8kHz		NTLab (Russia)
TSMC 130nm	4.25 Gb/s	Quad SerDes	Mixel (USA)
TSMC 28nm	PLL 2-3.6GHz	1ps jitter	Silicon Creation (USA
Chartered 350nm	PLL 300MHz		NTLab (Russia)

ADCs Power



P. O'Connor

Photo-multiplier readout

64-anode MaPMT photo-detector

16-channel ASIC in AMS 350nm Includes:

- Input integrator
- 8_bit ADC
- Parallel to Serial conversion



http://www.sciencedirect.com/science/article/pii/S0168900206008886#bib3

CMOS 8-bit ADC ramp generator

Veda

veca

vccd

Vin

veca

TØb

6Øx2

TØ 40×2

and

4Ø×4 Τ6 Τ4 20×4 20x4 - Charge capacitors at constant current Τ2 **Cascoded current sources (linearity)** 1Øx4 T5 - Two symetric ramps 2Øx4 20x4 Vout Τ3 - 5.12 µs duration 10×2 SC+ - Linearity 0.085% start+ vdda veca stort-SC-ТЗЬ 15×2 T7b T5b 10x3 1Øx3 T2b 5x3 T6b T4b J. Lecoq 1Øx3 10×3 T1b 20×3 gnd gnd gnd

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4V range

CMOS ADC latched comparator

J. Lecoq

- Differential
- Cascoded
- Positive feedback
- 300 μ V sensitivity

(AIZ @' ¢۵ T12 T5 TB cik D cmp2 vref+ T2 T3 T4 in+ vrefout out+ cmp1 10 Τ9 T13 14 VCCS Τ7 T8 Jand gnd gnd and

Silicon PMT readout

AMS SiGe 350nm technology line from LAL Orsay

Maroc 64-channel photon counting 1/3 Photo-Electron trigger sensitivity 50fC dynamic range Tunable slow channel for charge Tunable fast channel for timing Internal 8-12 ramp ADC

C de la Taille



Easiroc 32 inputs 8-bit DAC for gain adjustment Two control analog channels Fast trigger channels for timing Low power: 5mW/ch



Contact LAL Orsay: P Barrillon

http://www.omega.in2p3.fr (Need registration)

Full Orsay 0.35µm SiGe line

Chip	Optimized for	#ch #t	riggeı	rs Data type	Outputs	
MAROC	MaPMT	64	64	Th Q	1 Q analog +	· dig
SPIROC	SiPM	36		Th Q t	1 Q analog	Dig
EASIROC	SiPM	32	32	Th Q	2 Q analog	
HARDROC	RPC	64		Th Q	1 Q analog	Dig
MICROROC	MicroMegas	64		Th Q	1 Q analog	Dig
SKIROC	PIN diodes	64		Th Q	1 Q analog	Dig
PARISROC	PMTs Matrix	16	16	Th Q t		Dig
SPACIROC	MaPMT	64	64	Th Q	9 Q	

http://www.omega.in2p3.fr
Multi-anode PMT readout (JEM-EUSO)

C. de la Taille

AMS SiGe 350nm technology line from LAL Orsay

Spaciroc 64-channel photon counting for JEM-EUSO 1/3 Photo-Electron trigger sensitivity 10-1500 PE dynamic range Tunable slow channel for charge Tunable fast channel for timing Internal 8-12 ramp ADC Low power: 1mW/ch required by the ISS

http://www.omega.in2p3.fr

(Need registration)

Fast Switched Capacitors Arrays (SCA)

- Fast photo-detectors as Micro-Channel Plates or Silicon Photo-Multipliers signals analysed on-chip as with digital oscilloscopes
- Regular PMTs sampled to 13-bit dynamic range (E. Delagnes, D. Breton)

Principle of SCA ASICs:

Write fast (1-10GS/s) Read as possible (10-100 MHz) Digitize all caps in parallel with a ramp ADC Input discriminator as trigger to stop sampling

Key component of digital scopes

Examples:

- DRS4 S. Ritt (PSI)
- SAM D. Breton, E. Delagnes (France)
- LAB **G** Varner (Hawaii)
- PSEC H Grabas, E. Oberla (Chicago)

6GS/s	850 MHz	250nm
3GS/s	300 MHz	350nm
6GS/s	900 MHz	250nm
15GS/s	600 MHz	130nm

Random noise

imitations:

Sample aperture jitter Sampling timebase jitter





SCAs



- Sampling frequency
- Analog bandwidth
- Analog dynamic range (ADC bits)
- Depth
- Readout frequency

SCA sampling cell



L. Ruckman

Sampling cell + ADC

40 GS/s Timing generator



16 x 4 = 64 cells, 25ps step delays

J. Christiansen (CERN)

15 GS/s Timing generator



80 MHz sine wave sampled at 10GS/s





80 MHz, 100 mV pp sine wave sampled at 10 GS/s, after on-chip digitization and offset corrections

Eric Oberla (Univ Chicago)

SCA Offsets distribution



Offsets due to voltage threshold spreads (fixed pattern)

Eric Oberla (Univ Chicago)

VME board equipped with SCA chips (D. Breton, E. Delagnes)

Pipeline 12b 2GHz

©D. Breton



- Introduction

- Contexts

- High Energy Physics
- Space, Medical
- Photodetectors
 - Vacuum
 - Solid state
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 - Components
 - Technologies
 - Photon counting
 - Amplitude, charge
 - Imaging
 - Timing
 - 3D integration
- Conclusion

Charge Coupled Devices (CCD)

Set of electrodes on top of high resistivity silicon, top or backside illuminated Scientific CCDs: huge dynamic range (16-bit), single electron sensitivity if cooled.

Pixels are readout serially with fast amplifiers (one per electrodes array) Charge shifts horizontally into vertical registers which are readout serially.



- Transfer from cell to cell is noiseless, 99.999%... efficiency
- Charge is transfered from the last pixel to a voltage follower (floating gate) after reseting the node. The node is sensed before and after transfer

Correlated Double Sampling (CDS, eliminates reset noise)

CCDs readout



Digital Output

On readout chip capacitive transimpedance amplifier after on-CCD CDS

http://www.fairchildimaging.com/main/documents/CCD CMOS Hybrid FPA for Low Light Level Imaging.pdf



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CCD readout

- Most CCD noise is system noise after CDS
- Cooled at -100°C (173K), dark current is negligible
- Charge transfer efficiency almost perfect (i.e. 1 ppm charge diffusion)
- Companion (bi)CMOS ASIC needed for amplification, ADC, clock generation

CCD readout ASICs:

- ASPIC (LPNHE Paris) for the Large Synoptic Survey Telescope (LSST) focal plane at 173K. 350 CMOS.
 - > 16-bit dynamic range, noise < 7 μ V rms
 - Correlated Double Sampling
- CRIC (LBNL) for SuperNovae Acceleration Probe / Joint Dark Energy Mission (SNAP/JDEM). Space boarded telescope at 140K, 10 kRad tolerance. 250nm CMOS.
 - Correlated Double Sampling
 - > On-chip pipe-line ADC (13-bit),
 - noise < 6.8 μV rms
- Sidecar (Teledyne)
 - Up to 16 Mpixel support
 - 36 analog channels, Correlated Double Sampling
 - 16-bit ADC 100 kHz
 - 12-bit AC 10 MHz
 - CCD clock signals generation: kHz-MHz, 10-20V clocks

http://www.teledyne-si.com/imaging/sidecar.html

Monolithic Active Pixel Sensors (MAPS)



Monolithic Active Pixel Sensors (MAPS)

Pixel ADC: limited area

Time over threshold see FEI4 One comparator / pixel needed



C Hu, IPHC Strasbourg



R. Turchetta, RAL

IEEE Trans Nucl Sci Vol 57 n5 Oct 2010, p2490-2496

M. Tyndel, R. Turchetta et al

Monolithic Active Pixel Sensors (MAPS)



many chips



mimosa 01



mimosa 02



mimosa 03







mimosa 05



mimosa 05 + PCB



mimosa 05 wafer



mimosa 05 wafer



mimosa 05 wafer (detail)







AN ADDRESS OF A mimosa 08



mimosa 07



mimosa 07 layout





mimosa 08





Hybrid Pixel Sensors (see 3D section)



Detector of any material and type bump-bonded to readout electronics

2-tier (analog + digital) with Through Silicon Vias (TSV)

DEPFET readout CMOS 180nm

DEPFET: modulate the drain current of a MOSFET with ionisation created on the gate (MPI, Gemany)

DCDB Production Details

- Implemented in UMC 180nm CMOS technology
- Area: 3240x4969 μm²
- ~ 2x3 Mini@sic Blocks on a EuroPractice MPW run
- Additional 7th metal layer (redistribution layer) with bump-bond pads including bumps
- Production + bumping costs:
 ~ 20800 EUR (for 60 pcs.)
- · Production time: 5 months total
 - 3 months: MPW run

J. Knopf

2 months: 7th metal layer + bumping





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Timing techniques



Constant Fraction: Amplitude independent



Sample, digitize, Fit to the known waveform



Methods compared (simulation)



zoom

Time resolution vs Number of photo-electrons

Fast Timing Electronics

					lectronics
Constant fraction	SLAC	- NIM		6ps	3.4ps
	LBNL/Hawaii	- Discrete		·	·
Waveform analysis	Hawaii	- BLAB line chips	6GS/s	20ps	10ps
	Orsay/Saclay	- SAM line	2GS/s		
	PSI	- DRS line	5GS/s		
Under developm	nent:				
10-40 GS/s sam	npling chip (Chicago + Hawaii + C	Drsay/Sa	aclay	

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MCD Electronica

Time to Digital Conversion

Many custom ASICs based on analog or digital techniques

Analog

- Ramp between Tstart and Tstop
- Digitize level with an ADC, or ramp down slow and count

10ps resolution possible

Digital

- Count clock for coarse time (<100MHz)
- Interpolate with vernier digital delay lines locked on clock

10ps resolution possible

Hybrids !

HPTDC (CERN)

- 32 channels(100ps binning) or 8 channels (25ps binning)
- LVDS (differential) or LVTTL (single ended) inputs
- 40MHz time reference (LHC clock)
- Leading, trailing edge and time over threshold (for leading edge time corrections)
- Non triggered
- Triggered with programmable latency, window and overlapping triggers
- Buffering: 4 per channel, 256 per group of 8 channels, 256 readout fifo
- Token based readout with parallel, byte-wise or serial interface
- JTAG control, monitoring and test interface
- SEU error detection.
- Power consumption: 0.5W 1.5W depending on operating mode.







Pulse Sampling



Timing resolution

$$\sigma_t = \frac{\sqrt{t_r t_s}}{SN}$$

Stefan Ritt[,] PSI

Comes from :

Noise decreases as the root of the number of measurements

PSEC3 6-channel Sampling ASIC Specifications

10 GS/s sampling ASIC for Micro-Channel Plates Readout

Maximum sampling rate Analog Bandwidth Dynamic range Number of channels Number of cells Sampling window ADC Resolution Crosstalk DC Input impedance

Clock Conversion clock Readout time Power Process

15GS/s 2 GHz **V8.0** 6 256 adjustable 500ps-2ns 8-bit (12-bit implemented) 1% **50** Ω internal (channels 0 and 1) **50** Ω internal (channels 2 and 3) 40 MHz 1-2 GHz internal ring oscillator 4 x 256 x 25ns=25.6 ms 40mW/channel @ 1.2V IBM 8RF-DM (130nm CMOS)



Input analog bus laid out as a 50 Ω transmission line

RF design

Devices behaviour are more and more geometry dependent

- Controlled impedance 50 Ω paths
- Devices characterized by linear S (scatter) parameters
- Electromagnetic waves softwares

Tools for Silicon, GaAs, RF transmission lines,

- Network analysers
- Time Domain Reflectometry
- 50 Ω Calibrated components
- RF software layout and simulation tools Agilent ADS
 - Ansoft HFSS

RF design

DC-10 GHz simulations of a large area (20 x 20 cm) Micro-Channel Plate based detector using Ansoft HFSS electromagnetic simulator



Transmission line implemented on glass for 2D Micro-Channel plate readout Simulation shows that device is functional up to 2.3 GHz at 15dB

Pulse Sampling

ADC: Number of bits

Quantization noise is LSB/ $\sqrt{12}$ Signal noise should be significantly more than Q noise X_{max} Largest signal of interest :

Nbit = Log_2 (X max / LSB)

Sample rate $1/\tau$

 $1/\tau$ above twice the Shannon-Nyquist frequency: the highest frequency above noise NOT the 3dB cut-off:



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Processing of digital sampled data



Determine which information is useful in the waveform: Rising edge, integral, maximum amplitude.

For photo-detectors, usually time and charge (integral of the current pulse)

Pulse shaping can be done in digital if power and speed allow (ADC) 103

Fast timing: Processing of sampled data



Original MCP measured signal

Signal template (obtained by averaging 100 signals to remove noise)

Example: Least squares algorithm:

Minimize
$$\chi^2 = \sum_{i=1}^{N} (\mathbf{x}_{\text{meas}_i} - \mathbf{x}_{\text{temp}_i})^2$$

to get accurate time and maximum amplitude

Processing of digital sampled data





Obtain t_0 and x_{max} :

$$a = \sum_{i} x_{tempi}^{2} \quad bp = \sum_{i} x_{tempi}^{2} \quad b = \sum_{i} x_{tempi}^{2} \quad x_{tempi}^{2} \quad d = b^{2} - a \cdot bp$$

$$mp = \sum_{i} x_{measi}^{2} \cdot x_{tempi}^{2} \quad mp' = \sum_{i} x_{measi}^{2} \cdot x_{tempi}^{2}$$

$$\boxed{t_{0} = 1 / d (mp' \cdot b - mp \cdot bp) \quad x_{max} = -1 / t_{0} (mp' \cdot a / d + mp \cdot b / d)}$$
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LAPPD Collaboration

Transmission Line-MCP readout with PSEC-3



Digital filtering

Signal as a sequence of numbers, compute weighted sums with a Digital Signal Processor.

- Finite Impulse Response: convolution with the sampled impulse response
- Infinite Impulse Response: recursive, use of the z-domain frequency response:



Digital filtering

Example: 1st order RC filter


Pico-second timing and 2D position for large area detectors with delay lines

- Delay lines readout and pulse sampling provide
 - Fast timing (2-10ps)
 - One dimension with delay lines readout 100mm- 1mm Transverse dimension can be obtained from centroids

Less electronics channels for large area sensors



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3D Integration

Goal: increase the integration density

Interconnections: Two options: die to die

-1 Stack up several layers of different IC processes Interconnections. Through Silicon Vias (TSV) if more than 2 layers Die can be tested







2-tier

2-tier w/TSV

Multi-tier hybrid w/TSV

-2 2D in a thinner process

K. Torki

Limit of CMOS (10nm) is coming soon, option 1 will be mandatory In addition, thin processes are *always* expensive. But 3D could be as well...

3D tools emerging:

- Simulation
- Layout
- Extraction

http://cmp.imag.fr/SpI-Session_3DIC/02_CMP.pdf

3D Imagers

AREA 3D INTEGRATED IMAGERS

- Status: system architecture study of an imaging system on a chip-stack
- Integration of micro-optics layer:
 - Ultra wide field of view
 - Filters for hyperspectral imaging
- Shared pixels = multiple pixels per bump
- Smart analog/digital read-out:
 - Ultra high dynamic range
 - ADC per group of pixels
 - Variable resolution (active binning)
- Smart digital processing:
 - 2D distributed group of processors
 - Face recognition

Next step: demonstrator design and manufacturing

IMEC © IMEC

© IMEC 2010 PIET DE MOOR

Piet De Moor (IMEC), TWEPP 2010

3D Integration

- Shorter connections Lower impedance Less RC delays Save power
- Higher density Better heat Smaller I/O pitch

Area x Timing x Power = Factor 15



J.J Lu

Wafer bonding for 3D integration Cu on SiO_2 interconnect structures

Applications

- Memories, Memory on CPU
 - IBM, Samsung
- Pixellated photo-detectors:
 - Optics microlenses, filters,
 - Pixels Photo-Detector,
 - Electronics (analog + digital),
 - Serial opto out

MIT Lincoln Labs, RTI, Ziptronix



Key feature: Through Silicon Via (TSV)

2-tier 3D process tools

- PDK: from CMC +

TSVs from Tezzaron

- Libraries: Core + I/O from ARM
- Memory compiler:

S/DPRAM and ROM from A

-3 D Utilities:

Contributions development

-Tutorial, User's setup

Intallation easy



- Support of Cadence CDB and OpenAccess databases

K. Torki

3D process radiation hardness

FE-TC4-AE X-ray irradiation



A. Rozanov

CMC CMP Mosis FNAL Tezzaron



Singapore

Canada France

US

Access to 3D technology:

- 2-tier 130m CMOS
- Tezzaron, Globalfoundries
- Top tier exposing TSV
- Backside metal pads for wire bonding
- Design kit available

Discussions with LETI, AMS

Talk to: Kholdoun TORKI (CMP Grenoble, France)

http://cmp.imag.fr/products/ic/?p=130nmFaStack

1st MPW run



3D Integration CMP/MOSIS/CMC 1st MPW run



K.Torki

MPW run May 31st, 2011

Virtuoso Layout Editor with 3D layers



Tezzaron

True 3D Mask Editor



MicroMagix MAX 3D

Some ROIC Wafer Issues

- Frame size for adding Ziptronix DBI bonding pads was smaller than Chartered frame – repeat bond pad mask twice on 3D frame to avoid extra mask cost.
- Space was limited for different alignment targets needed for deposition of seed/DBI post metal and DBI bonding.
- IR transparent bond alignment targets are needed on each ROIC and sensor (conflicts with M6 density requirement)



R. Yarema



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Conclusion

Very promising developments open with 3D stacking allowing to use the most suited technologies for each purpose;

- Detection,

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y

- Amplification and filtering,
- Digital processing
- Deep Sub-Micron CMOS combined with Silicon-Germanium facilitate:
 - Low noise operation
 - High level of integration

to get more and more accurate in time and position photo-detectors...

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Thanks !

Extra slides

(Some) Photo-detectors

	Vacuum				
		Principle	Rise time	QE	Gain
•	Photo-multipliers	Dynode chain	1-5 ns	25-35%	10 ⁶⁻⁷
•	Hybrid Photo Diodes Hybrid APDs	Electrons on Si Electrons on APDs	1-5ns	25-35%	10 ²⁻⁴
•	Micro-Channel Plates	Micro-pores	100ps	25%	10 ⁶
	Solid state				
•	PIN diodes	Photo-electric	50ps		
•	Monolithic Active Pixel Sensors	Photo-electric	N/A		
•	Charge Coupled Devices	Photo-electric	N/A	20% front	N/A
				80% back	N/A
•	Avalanche Photo Diodes	Linear multiplicatio	n 2-5ns	30-70%	10 ¹⁻³
•	Silicon Photo-Multipliers	Geiger avalanche	200ps	90%	10 ⁶
•	CdTe/CdZnTe	X-ray			

Large Area Picosecond Photo-Detectors

U-Chicago leaded

- Large (20 x 20 cm²) Micro-Channel Plate (MCP) based
- Glass window and tray
- Photo-cathode
- Double Chevron structure
- Atomic Layer Deposition (ALD) processed

Readout Electronics

- Giga-Hertz Waveform sampling
- Application Specific Integrated Circuits (ASIC) based
- 130nm CMOS technology

Potential applications:

High Energy Physics:	Detectors, new acceleration techniques
Medical Imaging:	Positron Emission Tomography, dosimetry
Security:	Airports, trucks

Signal simple Spice model



Spice detector model: difference of two exponentials

50 Ω Cable driving Spice model



SPICE Model of PMT Cable Driving Circuit

Micro-Channel Plate Detectors



Micro-Channel Plates

Optimization for timing

Reduce Transit time

The thinner, the best Reduce pore size, primary and secondary gaps

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Avoid parasitic readout components

Connectors (!) Parallel capacitances Series inductances

Reduce rise-time, consequently improve time resolution

Imaging Micro-Channel Plates Detectors



Two-micron space resolution using analog charge division technique

R. Bellazzini et al. / Nuclear Instruments and Methods in Physics Research A 591 (2008) 125-128



Fig. 4. A profile along a line cut across the MCP pores of Fig. 3. The spatial resolution of the readout is $\sim 2 \,\mu m$ rms, capable of resolving every single MCP pore.

Micro-channel Plates Sampled Waveforms



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Synthesized signals for simulations

MCP signals: $(t/\tau)\exp(-t/\tau)\otimes(t/\tau)\exp(-t/\tau)$ τ is tuned to a 280ps rise-time





MCP Signals spectra



Single Threshold: Noise and Slope



Single threshold: Time spread proportional to amplitude noise and inverse to slope

Pulse sampling and Waveform analysis

- Sampling frequency: Set at twice the largest frequency in the signal spectrum



- Digitization:

Evaluate what is needed from signals properties:



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Sampled pulses analysis





- Extract precise time and amplitude from minimization of χ^2 evaluated wrt a template deduced iteratively from the measurements, at the two ends of the T-line.

- With T-lines, the two ends are highly correlated, so, MCP noise is removed.

Iterative template

At T-lines ends





Template from average std= 4.26ps

Template iterative std=3.93

Pulse sampling Timing resolution vs Sampling rate (simulation)



Timing resolution vs Sampling rate / Analog bandwidth

Pulse sampling benefits

Pulse sampling and waveform analysis:

- Picosecond timing with fast detectors
- Charge: centroids for 2D readout
- Resolve double pulse



For large area detectors read with delay lines in series



Position sensing using fast timing



• Edward May, Argonne:

Laser test bench calibrated with the single PE response of a Quantacon (single photon sensitive) PMT.

- 25/10um pores MCP on transmission lines card
- Scope triggered by the (somewhat jittery) laser signal
- Record two delay lines ends from the same trigger
- Tek 6154C scope at 20 Gs/s

Results



Position resolution (velocity=8.25ps/mm) :50PEs4.26ps213μm158PEs1.95ps97μm

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Measurements vs simulation

50PEs rms=3.82ps vs 2.5ps (simulation)

18PEs rms = 6.05ps vs 7ps (simulation)

Measurements do not match exactly since MCP noise is partly removed (T-lines ends correlated)



Position Resolution at 158PEs





2 4 Time

Transmission lines as anodes

- Present Photonis MCPs: Pixellated anodes, pitch of 1.6 x 1.6 mm
 - Atomic Layer Deposition (ALD) detectors
 - Waveform sampling with fast sampling chips
- Integration of lines as anodes in vacuum for large area sensors
- Plates of 1" x 1" in ALD process
- Modules of 8 " x 8 " ?

ALD micro-channel plate

glass

• One vacuum vessel (glass)

Henry Frisch, (U-Chicago) W. Hau, M. Pellin (ANL)

1"

Check in vacuum T-lines coupled to Micro-Channel Plates (impedance, velocity)

B. Adams, K Attenkoffer, ANL

MCPs: Best position resolution



Figure 1. Schematic of the cross strip anode showing the MCP charge cloud, and charge distribution on the cross strips.

A few microns position resolution using analog weighted sums

O. Siegmund, A. Tremsin (SSL Berkeley)

350nm Silicon-Germanium

Silicon PMs Readout: SPIROC

- 32-Channel ASIC for Silicon PM readout Includes 32 x 16-deep analog memories and ADCs
- Internal input 8-bit DAC (0-5V) for individual SiPM gain adjustment
- Energy measurement : 14 bits
 - 2 gains (1-10) 1 pe → 2000 pe
 - Variable shaping time from 25ns to 175ns
 - pe/noise ratio : 11
 - 2 Multiplexed outputs for low gain and high gain

Trigger output

- pe/noise ratio on trigger channel : 24
- Fast shaper : ~10ns
- Trigger on 1/3 pe (50fC)
- 32 trigger outputs
- OR 32 output
- Trigger latch for each channel and multiplexed output
- Individually addressable calibration injection capacitance
- Embedded features
 Power pulsing, bandgap, 10-bit DAC





Switched Capacitor Arrays (SCA)

- Sampling capacitors: 50-100 fF, input bus 200-1k Ω
- Analog bandwidth = $1/2\pi RC$ = 1-10GHz
- Dynamic range 10-13 bits limited by noise and voltage droop before readout
- Timing generator using voltage controlled delay elements of 50-500ps
- Depth can be very large (64k) if bandwidth is not constrained
- Very low power (readout dominated)

